

<b>Notice of References Cited</b>	Application/Control No. 09/966,294	Applicant(s)/Patent Under Reexamination LAVRETOVICH ET AL.	
	Examiner A. Sefer	Art Unit 2826	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,680,185	10-1997	Kobayashi et al.	349/88
	C	US-2004/0032561	02-2004	Kumar et al.	349/156
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	K	US-			
	L	US-			
	M	US-			

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	N	WO 96/06380	02-1996	PCT	Van Haaren et al.	
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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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